PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul B. Mirkarimi et al.

Docket No.

: CIL-10972

Serial No.: 10/086,614

Art Unit

: 1762

Filed

AUG 2 2 2005

: March 1, 2002

Examiner

: W. Markham

For

: Ion-Assisted Deposition Techniques For

The Planarization Of Topological Defects

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

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